

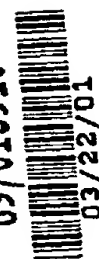
PATENT APPLICATION

Sheet 1 of 1

FORM PTO-1449 LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	ATTY. DOCKET NO. 10004618-1	SERIAL NO.
	APPLICANT Yong Chen	
	FILING DATE Herewith	GROUP 1763

11040 U.S. PTO

09/815913



REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
<i>Ad</i>	1A	6,165,911	Dec. 26, 2000	Calveley		
	1B	6,136,208	Oct. 24, 2000	Chou et al.		
	1C	5,801,472	Sep. 1, 1998	Wada et al.		
	1D	5,772,905	Jun. 30, 1998	Chou		
	1E	5,535,185	Jul. 9, 1996	Kishi et al.		
<i>Ad</i>	1F	5,038,322	Aug. 6, 1991	Van Loenen		
	1G					
	1H					
	1I					
	1J					
	1K					

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	TRANSLATION	
							YES	NO
	1L							
	1M							
	1N							
	1O							
	1P							

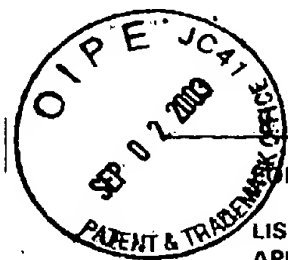
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

<i>Ad</i>	1Q	Stephen Y. Chou et al., "Imprint Lithography with 25-Nanometer Resolution," Science, vol. 272 (Apr. 5, 1996).
	1R	
	1S	

EXAMINER

DATE CONSIDERED

2/22/2004



PATENT APPLICATION

Sheet 1 of 1

FORM PTO-1449

LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S INFORMATION DISCLOSURE
STATEMENT

(Use several sheets if necessary)

ATTY. DOCKET NO.

10004618-1

APPLICATION NO.

09/815,913

CONFIRMATION NO.

6205

APPLICANT

Yong Ch n

FILING DATE

03/22/2001

GROUP

1763

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	PUBLICATION DATE	NAME	Pages, Columns, Lines Where Relevant Passages or Figures Appear
<i>Acus</i>	1A	5,317,141	05/31/1994	Thomas	
	1B	5,772,905	06/30/1998	Chou	DUPLICATE
	1C				
	1D				
	1E				
	1F				
	1G				
	1H				
	1I				
	1J				
	1K				

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	PUBLICATION DATE	NAME OF PATENTEE OR APPLICANT	Pages/Columns/Lines Where Relevant Passages/Figures Appear	Check if Translation attached
<i>Acus</i>	1L	04342112	11/27/1992	Olympus Optical Co		
<i>Acus</i>	1M	WO02/17383	02/28/2002	Board of Regents		
	1N					
	1O					
	1P					

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

<i>Acus</i>	1Q	D L White and O R Wood - "Novel Alignment System for Inprint Lithography" - J Vac Sci Technol B 18(6) Nov/Dec 2000 - pages 3552-3556
	1R	
	1S	

EXAMINER

DATE CONSIDERED

2/22/2004